

PTO/SB/08A		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	10/039,196
		Filing Date	January 2, 2002
		Confirmation Number	7221
		First Named Inventor	Robert J. Falster
		Group Art Unit	1705 1772
		Examiner Name	Jane Rhee
Sheet	1	of	2
		Attorney Docket No.	MEMC 00-1400 (2806.1)



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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Number	Kind Code ² (if known)		
	1	5,919,302	11/13	Falster et al.	07-06-1999
	2	5,994,761	25/10/11	Falster et al.	11-30-1999
	3	6,180,220	42/32/4	Falster et al.	01-30-2001
	4	6,191,010	42/3/47	Falster	02-20-2001
	5	6,254,672	11/13	Falster et al.	07-03-2001
	6	6,287,380	11/13	Falster et al.	09-11-2001
	7	6,336,968	11/12	Falster	01-08-2002
OTHER ART - NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.			T ³
	8	R. FALSTER "The Phenomenology of Dielectric Breakdown in Thin Silicon Dioxide Films: Al Cathodes and p-type Si Anodes" J. Appl. Phys., Vol. 66, No. 7 (1989) pp. 3355-3370.			
	9	R. FALSTER et al. "On the Properties of the Intrinsic Point Defects in Silicon: A Perspective from Crystal Growth and Wafer Processing" Phys. Stat. Sol. (b), Vol. 222, No. 1 (2000) pp. 219-244.			

Examiner Signature		Date Considered	3/4/01
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*EXAMINER Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered include copy of this form with next communication to applicant.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT



Application Number	10/039,196
Filing Date	January 2, 2002
Confirmation Number	7221
First Named Inventor	Robert J. Falster
Group Art Unit	1765 1772
Examiner Name	Jane Rhee
Attorney Docket No.	MEMC 00-1400 (2806.1)

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PTO/SB/08A				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	10/039,186
				Filing Date	January 2, 2002
				Confirmation Number	7221
				First Named Inventor	Robert J. Falster
				Group Art Unit	1765
				Examiner Name	Benjamin L. Utech
Sheet	1	of	1	Attorney Docket No.	MEMC 00-1400(2806.1)

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		Number	Kind Code ² (if known)				
	15	5,502,010		Nadahara et al.	03-26-1996		
FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T ³
		Office	Number ⁴	Kind Code ² (if known)			
	16	WO	98/45507	A1	MEMC Electronic Materials, Inc.	10-15-1998	
	17	WO	00/00675	A1	MEMC Electronic Materials, Inc.	01-06-2000	
OTHER ART - NON PATENT LITERATURE DOCUMENTS							
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.					T ³
	18	Partial International Search for analogous PCT application Serial No. PCT/US02/01127 dated September 9, 2002.					
Examiner Signature				Date Considered	12/13/04		

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¹Unique citation designation number. ²See attached kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached or place an "A" here if English language abstract is attached.

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